



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Patent Application of:

Toru TAKAYAMA et al.

Serial No. 10/650,046

Filed: August 28, 2003

For: MANUFACTURING METHOD FOR A
SEMICONDUCTOR DEVICE AND
HEAT TREATMENT METHOD
THEREFOR

) Group Art Unit: 2813

) Examiner: T. Nguyen

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is
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) Ashley M. Stampen

RESPONSE TO ELECTION REQUIREMENT


Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the election requirement in the Official Action mailed September 8, 2004, Applicant hereby elects without traverse Species 1, drawn to a method for forming a semiconductor device. Claims 1-57 read on the elected species.

Examination on the merits is requested.

Respectfully submitted,


Eric J. Robinson
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